Serial Number: 09/825,611 Filing Date: April 3, 2001

Title: METHOD FOR PECVD DEPOSITION OF SELECTED MATERIAL FILMS

Page 6 Docket No: 303.930US3

## Remarks

Claims 67-85 are added. As a result claims 37-39 and 67-85 are now pending in the application. The present paper supplements the Amendment and Response filed December 16, 2005. Entry of the present amendment is requested. Applicant respectfully submits that the claims are in condition for allowance and notification to that effect is earnestly requested. The Examiner is invited to telephone Applicant's attorney at (612) 349-9587 to facilitate prosecution of this application. If necessary, please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

Respectfully Submitted,

SUJIT SHARAN ET AL.

By their Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A. P.O. Box 2938 Minneapolis, MN 55402 (612) 349-9587

Reg. No. 40,957

CERTIFICATE UNDER 37 CFR § 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this <u>3</u> day of <u>January</u> 2006.

Name KACIA LEE	Signature	Karia Lee
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